

ABSTRACT

[0075] There is disclosed a method of forming a patterned conductive element for an implantable medical device, the method comprising the steps of:

- (i) depositing a supplementary material on a sheet of conductive, parent material (1) to form a sheet of composite material;
- (ii) applying a carrier material over the supplementary material **[(3)]** of the composite sheet to form a sheet of semi-finished material;
- (iii) removing portions from at least the conductive parent material of the sheet of semi-finished material in accordance with a desired pattern corresponding to a patterned conductive element to be formed; and
- (iv) releasing at least the carrier material **[(4)]** from the sheet of semi-finished material.